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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Stephen W. Bedell, et al.

Docket: 17032

Patent No.: 6,825,102

Dated: April 6, 2005

Issued: November 30, 2004

**For: METHOD OF IMPROVING THE QUALITY
OF DEFECTIVE SEMICONDUCTOR
MATERIAL**

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

LETTER TO THE COMMISSIONER

Sir:

**Applicant's hereby make of record the following errors which appear in the
above-identified Patent:**

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

**I hereby certify that this correspondence is being deposited with the United
States Postal service as first class mail in an envelope addressed to: Commissioner for
Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on**

Dated: April 6, 2005



Leslie S. Szivos

Column 8, Line 44-45 "out a" should read -- out at a --

Respectfully submitted,

A handwritten signature in black ink, appearing to be 'LS', with a long horizontal line extending to the right.

**Leslie S. Szivos
Reg. No. 39,394**

**Scully, Scott, Murphy & Presser
400 Garden City Plaza, Suite 300
Garden City, New York 11530
(516) 742-4343
LSS/al**